



SHEET 1 OF 1

LIST OF ART CITED BY APPLICANT
(PTO-1449)ATTY. DOCKET NO.
YHK-0121APPLN. SERIAL NO.
10/675,987

APPLICANT(S)

Eung Chul PARK

FILING DATE
October 2, 2003GROUP
2879**U.S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE

U.S. PATENT APPLICATION PUBLICATIONS

	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS	

U.S. PATENT APPLICATIONS

	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS	

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
S.R.	JP 2000-156166	6/6/2000	Japan (1 st page w/English Abstract)			X	
S.R.	JP 09-208851	8/12/1997	Japan (1 st page w/English Abstract)			X	
S.R.	JP 10-334809	12/18/1998	Japan (1 st page w/English Abstract)			X	
S.R.	JP 2004-047193	2/12/2004	Japan (1 st page w/English Abstract)			X	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)

Japanese Office Action dated December 16, 2005

EXAMINER

Sikha Roy

DATE CONSIDERED

2/8/06

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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